



IFW

PATENT
Docket No. 2557-000177/US

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Chang Won CHOI et al. Conf.: 5346
Appl. No.: 10/762,526 Group: 1763
Filed: January 23, 2004 Examiner: Jeffrie R. Lund
For: WAFER EDGE ETCHING APPARATUS AND METHOD

REPLY TO NOTICE OF NON-COMPLIANCE

Customer Service Window
Randolph Building
401 Dulany Street
Alexandria, VA 22314

February 5, 2007

Sir:

In reply to the Notice of Non-Compliance mailed January 29, 2007, Applicants attach hereto a marked-up version of the claims filed on November 6, 2006 as requested by the Examiner.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 08-0750 for any additional fee required under 37 C.F.R. §§ 1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

HARNES, DICKEY & PIERCE, P.L.C.

By

John A. Castellano, Reg. No. 35,094

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JAC/pw

Attachment: Claims Section of Amendment filed November 6, 2006